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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Shunsuke SHUTOU**

Group Art Unit: **Not yet assigned**

Serial Number: **10/557,837**

Examiner: **Not yet assigned**

Filed: **November 21, 2005**

Confirmation Number: **6758**

For: **METHOD FOR PRODUCING ANISOTROPIC FILM**

Attorney Docket Number: **053078**

Customer Number: **38834**

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §1.97(b)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

February 21, 2006

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. This paper is being filed within the time periods set forth in 37 C.F.R. §1.97(b). A copy of each non-U.S. document is enclosed herewith.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

[Signature]
Stephen G. Adrian

Attorney for Applicants

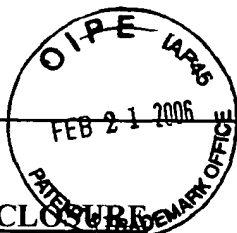
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14 References



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Complete if Known

Sheet	1	of	1	Application Number	10/557,837
				Confirmation Number	6758
				Filing Date	November 21, 2005
				First Named Inventor	Shunsuke SHUTOU
				Art Unit	Not yet assigned 1792
				Examiner Name	Not yet assigned Ronald Lafond
				Attorney Docket Number	053078

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
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		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
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	3	JP	2990270	B2	10-15-1999	Agency Ind. Science Techn.	Abstract, JPO
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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
/R.L./	12	MARTIN SCHADT et al., "Surface-Induced Parallel Alignment of Liquid Crystals by Linearly Polymerized Photopolymers", Jpn. J. Appl. Phys. Vol. 31, pp. 2155-2164 (1992)	N/A
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	14	M. NISHIKAWA et al. "Effect of chemical structures of polyimides on photosensitivity of liquid crystal alignment using a polarize UV exposure", Liquid Crystals, Vol. 26, No. 4, pp. 575-580 (1999)	N/A
	15	KUNIIKO ICHIMURA, "Photocontrol of Liquid Crystal Alignment", Applied Physics, Vol., 62, No. 10, pp. 998-1001 (1993)	Partial

Examiner Signature	/Ronald Lafond/ (11/07/2007)	Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.